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501.37465CC9

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Yoshikazu TANABE, et al.

Serial No.:

10/774,589

Filed:

February 10, 2004

For:

METHOD FOR FABRICATING SEMICONDUCTOR

INTEGRATED CIRCUIT DEVICE

Group:

2829

Examiner:

Not yet assigned

## <u>UNDER 37 CFR §§1.97 and 1.98</u>

## **Mail Stop Amendment**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 June 1, 2004

Sir:

Pursuant to Applicants' duty to disclosure, enclosed please find a copy of a U.S. Patent, recently discovered, for consideration by the Examiner during examination of the above-identified application. Also enclosed is a Form, substantially equivalent to Form PTO-1449, listing this enclosed document.

This Information Disclosure Statement is being submitted prior to a first Office Action on the merits in the above-identified application. Accordingly, requirements of 37 CFR §1.97(b) are satisfied.

In view of the foregoing, it is respectfully submitted that all applicable requirements of 37 CFR §§1.97 and 1.98 have been satisfied, in connection with the document listed on the enclosed Form. Accordingly, consideration of the listed

Appl. No. 10/774,589 Information Disclosure Statement dated June 1, 2004

document, upon examination of the above-identified application, is respectfully requested.

Please charge any shortage of fees due in connection with the filing of this paper, including extension of time fees, to the Deposit Account of Antonelli, Terry, Stout & Kraus, No. 01-2135 (Application No. 501.37465CC9), and please credit any excess fees to said deposit account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

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PTO/SB/08A (10-01)
Approved for use through 10/31/2002. OMB 0651-0031
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collection of information unless it contains a valid OMP control number

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Substitute for form 1449A/PTO				Complete if Known			
				Application Number	10/774,589		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Filing Date	February 10, 2004		
				First Named Inventor	Yoshikazu TANABE		
				Art Unit	2829		
(use as many sheets as necessary)			y)(y	Examiner Name	Not yet assigned		
Sheet	1	of	1	Attorney Docket Number	501.37465CC9		

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Examiner Initials'	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code <sup>2</sup> (if known)			
		US-			
		US-			
		US- 6,110,531	08-29-2000	PAZ DE ARAUJO et al.	
		US-			
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		US-			
		US-			

FOREIGN PATENT DOCUMENTS						
Examiner Initials'	Cite No. <sup>1</sup>	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sub>6</sub>
		Country Code <sup>3</sup> -Number <sup>4</sup> -Kind Code <sup>5</sup> (if known)				
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Examiner	Date	
Signature	Considered	

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<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at <a href="https://www.uspto.gov">www.uspto.gov</a> or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard St.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁴Applicant is to place a check mark here if English language Translation is attached.